



PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

November 28, 2001

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TECHNOLOGY CENTER R3700

Applicant(s): Wolfgang FRITZ

For: DEVICE AND PROCESS FOR THE PRODUCTION OF GASKET LAYER

Serial No.: 09/892 052

Group: 3729

Filed: June 26, 2001

Examiner: Unknown

Atty. Docket No.: HOE605

Confirmation No.: 1771

Assistant Commissioner for Patents
Washington, DC 20231

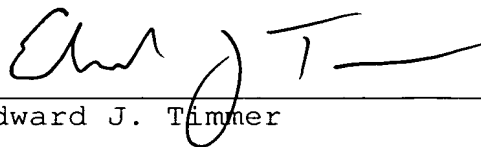
INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the provisions of Rules 1.97(b)(3) and 1.98, enclosed herewith is Form PTO-1449 and the reference cited thereon. Accordingly, further comment at this point in time should not be necessary.

Further consideration is respectfully solicited.

Respectfully submitted,



Edward J. Timmer

EJT/ad

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5955 W. Main St.
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Encl: Form PTO-1449
One copy of each cited reference
Postal Card

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PATENT APPLICATION

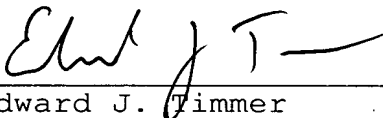
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FIRST CLASS MAILING CERTIFICATE

Sir:

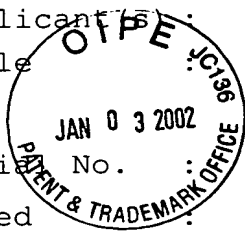
I hereby certify that this correspondence is being deposited with the United States Postal Service under 37 CFR 1.8 as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington DC 20231, on November 28, 2001.


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Correspondence: Information Disclosure Statement including
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